



**DEPARTMENT OF ELECTRICAL ENGINEERING
NATIONAL INSTITUTE OF TECHNOLOGY, RAIPUR**

Phone: 0771-2254200, Fax: 0771 – 2254600

ADVERTISEMENT NO: NITRR/EED/2023/98070 dated 13/01/2023

SERB project entitled “3D printed substrate integrated hollow waveguide based photoacoustic interferometry for eNO detection”

Application for Junior Research Fellow

1. Name of Applicant:

2. Address:

Phone:

Email ID:

3. Date of Birth (Age):

4. Nationality:

5. Category:

6. Sex:

7. Complete Academic Record (Starting from X standard) (attach certificates):

S. No.	Exam/Degree	Specialization	Board/University/ Institute	Year of Completion	% Marks and Division
1					
2					
3					
4					

8. Areas of Interest:

9. Publications/conference participation (National/International) (Attach proofs):

10. Research experience (Attach proof):

11. Whether GATE/CSIR-UGC NET qualified (Attach proof):

12. Any Other Relevant Information:

UNDERTAKING

I understand that it is a contractual engagement on a purely temporary basis for the Project. I declare that the abovementioned details are correct to the best of my knowledge and belief. I understand that action can be taken against me if these are found to be incorrect. I agree to all the terms and conditions of the associated advertisement, SERB, India and NIT Raipur.

Date:

Place:

Signature of Applicant

Note: Attach the relevant self-attested copy of certificates/documents with the application

Paste your passport
size self-attested
Photograph